

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Bradley F. Bowden

Kenneth E. Hrdina

Serial No:

10/086,238

Filed:

February 27, 2002

FABRICATION OF INCLUSION FREE

DMOGENEOUS GLASSES

RECEIVED TO 1700 INFORMATION DISCLOSURE STATEMENT **UNDER 37 C.F.R.** §§ 1.56, 1.97 – 1.98

isticaler of Patents and Trademarks

Washington, DC 20231

2002

Dear Sir:

The Examiner's attention is hereby directed to the following reference(s) listed on the attached Form PTO-1449 for consideration in connection with the examination of the above-identified patent application. One copy of the reference(s) is enclosed.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the enclosed documents constitute "prior art." If it should be determined that any of the submitted documents do not constitute "prior art" under United States law, applicant(s) reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

Applicant(s) further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the enclosed references, should one or more of the references be applied against the claims of the present application.

Respectfully submitted,

Timothy M. Schaeberle Registration No. 34,424 Corning Incorporated

SP-TI-03-1

Corning, NY 14831

(607) 974-3/16/4

CERTIFICATE OF MAILING

Examiner: To Be Assigned

Group Art Unit: 1731

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Asst. Commissioner of Patents and Trademarks, Washington, D.C. 20231

Date of Deposit

ignature: Colleen E. Doherty

Revision: March 7, 2000

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RM PTO-1449 (MODIFIED)

JUN 1 9 2002 LIST OF PATENTS AND
PUBLICATIONS
PRADERFOR APPLICANTS INFORMATION
DISCLOSURE STATEMENT

ATTORNEY DOCKET NO.

SP01-330

SERIAL NO.

10/086,23

APPLICANT Bowden et al.

FILING DATE February 27, 2002

GROUP: 1731

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

				THE PROPERTY OF THE PROPERTY O	THE ENT BOCOMENTS				
Examiner Initial		Document Number	Date	Name	Class	Sub- Class	Filing Date if Approp.		
	AA	2,326,058	8/3/43	Nordberg	100	52			
	AB	4,501,602	2/26/85	Miller et al.	65	18.2			
	AC	5,043,002	8/27/91	Dobbins et al.	65	3.12	-		
	AD	5,152,819	10/6/92	Blackwell et al.	65	3.12			
	AE	5,154,744	10/13/92	Blackwell et al.	65	3.12			
	AF	5,686,728	11/11/97	Shafer	250	492.2			
	AG	5,970,751	10/26/99	Maxon et al.	65	414	<u> </u>		
	AH	6,013,399	1/11/00	Nguyen	430	5			
	AI	6,299,318	10/9/01	Braat	359	856			

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub- Class	Trans Yes	lation No
	<u>AJ</u>	WO 01/07967 •	2/1/01	PCT	G03C	5/00	X	
	AK_	WO 01/08163 °	2/1/01	PCT	G21K	5/00	X	-
	AL	WO 01/75522 °	10/11/01	PCT	G03F	1/14	X	
	AM	WO 00/48775 •	8/24/00	PCT	B23B		X	
	AN	WO 02/32622,	4/25/02	PCT	B24B	7/24	X	
	AO	WO 02/26647 •	4/4/02	PCT	C03B	37/016	X	
T A	AP	WO 02/32616 ·	4/25/02	PCT	B23P	13/04	A	 ;
	\overline{AQ}	EP 0 903 605A2	3/24/99	EPO	G02B	13/14	X	
<i>F</i>	AR	EP 1 106 582A2	6/13/01	EPO	C03B	19/10	X	

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



ARCANA SOUND TO THE SOUND TO TH OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.) P. Shultz & H. Smith, Ultra-Low-Expansion Glasses and Their Structure in the SiO₂-A1 TiO₂ System, Amorphous Materials, papers presented to the Third International Conference on the Physics of Non-Crystalline Solids, held at Sheffield University, September 1970 George H. Beall, Industrial Applications iof Silica, Reviews in Mineralogy, Vol. 29 A2 (Silica), (1994), 469-505. -Charles Gwyn et al., Extreme Ultraviolet Lithography, November 1999, 97-141. , A3 EUV Lithography NGL Technology Review, June 9, 1999, Chicago, Illinois , A4 Charles Gwyn et al., Extreme Ultraviolet Lithography, 1-6. • A5 William M. Tong et al., Substrates Requirements For Extreme Ultraviolet Lithography, ,A6 Information Science & Technology, Lawrence Livermore National Laboratory, . December 1999. O.V. Mazurin et al., Crystallizaiton of Silica and Titanium Oxide-Silica Corning ,A7 Glasses (Codes 7940 & 7971), Journal of Non-Crystalline Solids 18, (1975) 1-9. ISIMOTO CO. LTD., Purity and Chemical Reactivity, /A8 http://www.isimoto.com/isimoto/english/feature1.html, 1-3, 5/17/99 ISIMOTO CO. LTD., Product Information, **∠**A9 http://www.isimoto.com/isimoto/english/product_info.html, 1-4, 5/17/99 Rapid Prototyping, http://mtiac.iitri.org/pubs/rp/rp1.htm _A10 Products: SLS (R) Systems – Introduction, Vanguard™ and Vanguard™ HS, • A11 http://www.3dsystems.com/products/slssystems/vanguard/index.asp?promo= Corning, Semiconductor Materials ULE Zero Expansion Glass, A12 http://www.corning.com/semiconductormaterials/products_services/ule.asp Richard H. Stulen et al., Extreme Ultraviolet Lithography, IEEE Journal of Quantum A13 Electronics, Vol. 35, No. 5, May 1999, 694-699.. • DATE CONSIDERED:

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